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# Enhanced emission from ZnO-based double heterostructure light-emitting devices using a distributed Bragg reflector

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Double hetero-structured n-Mg $_{0.13}$ Zn $_{0.87}$ O/i-ZnO/p-Mg $_{0.13}$ Zn $_{0.87}$ O light-emitting devices (LEDs) have been fabricated, and the p-type Mg $_{0.13}$ Zn $_{0.87}$ O layer was obtained via a lithium–nitrogen codoping method. Obvious emission at around 400 nm has been observed from the LEDs under forward bias. To increase the light extraction from the LEDs, a distributed Bragg reflector whose reflectivity is 98% at 400 nm was bonded on the back side of the device, and the emission of the device was enhanced by around 1.6 times with the reflector.

#### Introduction

The large exciton binding energy (60 meV) of ZnO suggests that efficient excitonic emission may be realized, thus a variety of potential applications including lighting, displaying, signalling, etc. may be expected from ZnO.1-4 Although much attention has been paid, the reports on efficient ZnO-based light-emitting devices (LEDs) are still rare, and most of them are realized in simple p-ZnO/n-ZnO structures.5-10 It is accepted that in the p-ZnO/n-ZnO structures, since the mobility of electrons are usually larger than that of holes, the electrons and holes tend to recombine in the p-type ZnO region. Considering that there are many residual donor-related defects and introduced acceptorrelated defects in this layer, emission from donor-acceptor pairs usually dominates the emission of p-ZnO/n-ZnO structures. 6,9,10 By employing MgZnO/ZnO heterostructures the recombination region of electrons and holes can be confined into the ZnO layer, and the excitonic near-band-edge emission of ZnO can be obtained.11,12 Nevertheless, very few reports on ZnO-based heterostructure LEDs can be found up to date, and most of which are focused on single-heterostructures, 11,13-16 In this communication, n-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O/i-ZnO/p-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O double heterostructured LEDs have been constructed, in which the p-type Mg<sub>0.13</sub>Zn<sub>0.87</sub>O layer was obtained by employing Li and N codoping method. Obvious emission at around 400 nm has been observed from the LEDs under the injection of continuous current. To increase the emission of the LEDs, a distributed Bragg reflector (DBR) whose reflectivity is about 98% at around 400 nm has been bonded onto the backside of the LEDs. It is found that the emission of the LEDs can be increased significantly.

## Experimental

The  $n-Mg_{0.13}Zn_{0.87}O/i-ZnO/p-Mg_{0.13}Zn_{0.87}O$  double heterostructures were grown by plasma-assisted molecular beam epitaxy technique (VG V80H), and a-plane sapphire was employed as a substrate. Either lithium or nitrogen has been employed to synthesize p-type ZnO-based films before.22-26 In this communication, we use Li and N codoping method to obtain p-type MgZnO. The detailed growth conditions for the n-MgZnO and p-MgZnO can be found elsewhere.27 Metallic zinc, lithium and magnesium contained in individual Knudsen effusion cells were used as the Zn, Li and Mg source. Nitric oxide (NO) was used as N and O sources for the growth of the p-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O layer and oxygen (O<sub>2</sub>) was used as O source for the growth of intrinsic ZnO (i-ZnO) and n-Mg $_{0.13}$ Zn $_{0.87}$ O. The gas sources were activated by an Oxford Applied Research HD25 radio-frequency (13.56 MHz) atomic source at a power of 300 W. The pressure in the growth chamber was fixed at  $2 \times 10^{-5}$  mbar, and the flow rate of NO and O2 at 0.88 and 1.0 sccm during the growth process. The sapphire substrate was pretreated at 400 °C for 30 min to remove the possible surface contaminants before being loaded into the growth chamber. A ZnO film was employed to buffer the growth of the n-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O/ZnO/ p-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O double heterostructures. The substrate temperature was kept at 650 °C during the growth of the

while the reports on double heterostructure ZnO LEDs are still rare.  $^{17\text{-}21}$ 

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n-Mg $_{0.13}$ Zn $_{0.87}$ O and p-Mg $_{0.13}$ Zn $_{0.87}$ O layer, while it was kept at 750 °C for the growth of the i-ZnO layer.

The electrical properties of the ZnO films were measured in a Hall measurement system (LakeShore 7707) under Van der Pauw configuration. The structural properties of the films were characterized in a Bruker-D8 X-ray diffractometer. The composition of the MgZnO layers was determined using a VG ESCALAB MK-II X-ray photoelectron spectroscope (XPS). Photoluminescence (PL) spectra of the films were recorded employing the 325 nm line of a He–Cd laser as the excitation source. Electroluminescence (EL) measurements were carried out in a Hitachi F4500 spectrometer under the drive of a continuous current. Finite-different time-domain (FDTD) method was used to simulate the electromagnetic field distribution in the devices.

#### Results and discussion

The schematic diagram of the double heterostructure is shown in Fig. 1(a). Note that the electron concentration and Hall mobility of the ZnO buffer layer are  $2.7 \times 10^{19} \, \text{cm}^{-3}$  and  $35 \, \text{cm}^2$ V<sup>-1</sup>s<sup>-1</sup>, respectively. An n-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O layer was firstly grown on the ZnO film as an electron source. The thickness of the n-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O layer is about 150 nm. Then a 40 nm undoped i-ZnO was deposited onto the n-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O layer as an active layer. Subsequently, a 100 nm p-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O:(Li,N) layer was deposited on ZnO layer as the hole source layer. Indium (In) and Ni/Au were coated onto the ZnO buffer and p-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O layers acting as ohmic contact by thermal evaporation method. The current-voltage (I-V) characteristic of the heterostructure shows obvious rectification behaviors with a turn-on voltage of around 3.6 V, as shown in Fig. 1(b). The inset shows that the I-V curves for both In contact on the n-ZnO and Ni/Au contact on the p-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O, both of which are nearly beelines, indicating that ohmic contacts have been formed in both cases. The ohmic behaviors of the metal contacts exclude the possibility of the formation of any Schottky junctions in the heterostructures.

Since the optical quality of the ZnO active layers is fundamental for the performance of the heterostructure LEDs, the PL spectrum of the ZnO active layer has been measured, as shown in the inset of Fig. 2. The spectrum shows a sharp peak at

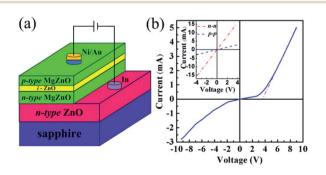


Fig. 1 (a) Schematic illustration of the n-Mg $_{0.13}$ Zn $_{0.87}$ O/i-ZnO/p-Mg $_{0.13}$ Zn $_{0.87}$ O double heterostructure. (b) I-V curve of the double heterostructure, and the inset shows the I-V curves of the Ni/Au contact to the p-Mg $_{0.13}$ Zn $_{0.87}$ O layer and the In contact to the n-ZnO layer.

around 375 nm, which is the near-band-edge emission of ZnO, and a weak deep-level emission at around 500 nm can also be observed from the spectrum. The room temperature EL spectra of the double heterostructure are shown in Fig. 2. One can see that the emission is dominated by a band at around 400 nm, and another weak one at around 500 nm is also visible in the spectrum. The former has been commonly observed from ZnObased LED, which can be attributed to the near-band-edge emission of ZnO.11 As for the emission at around 500 nm, it can be attributed to the deep-level related emission of ZnO. 28,29 With the increase of the injection current from 30 mA to 80 mA, the intensity of the emission at around 400 nm increases significantly, and the peak of the emission redshifts from 395 nm to 405 nm. The redshift may come from the quantum confined Stark effect and/or the heating effect caused by the relatively large injection current in the structure.30,31

The distribution of the electromagnetic field of the emitted photons in the device has been simulated using FDTD method.32,33 Take the effect of DBR into account, the cross section of the device with x-y plane was built to demonstrate the electromagnetic field distribution without and with the DBR. The incident light is parallel to y axis, which is shown in the inset of Fig. 3(b) and (d). One can see from the electromagnetic field distributions E (x, y) of the n-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O/i-ZnO/ p-Mg<sub>0.13</sub>Zn<sub>0.87</sub>O heterostructure without the DBR shown in Fig. 3(b) that the emission is mainly located in the vicinity of the i-ZnO layer, while only a very small portion of the emitted photons can come out of the device, and be captured by the recording detector, which means that the extraction efficiency of the LEDs is very low, and the low extraction efficiency of the emitted photons is seriously adverse to the performance of the devices. It is accepted that the major reason for the low extraction efficiency lies in the fact that the refraction index of ZnO (2.45) is much larger than that of air ambient (1.0). In such circumstance, many emitted photons will encounter total

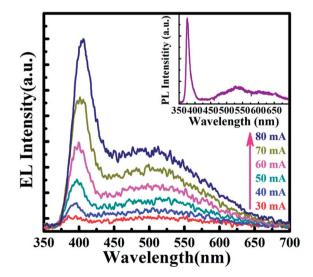


Fig. 2 Room temperature EL spectra of the double-heterostructure at different injection current, and the inset shows the room temperature PL spectrum of the ZnO active layer.

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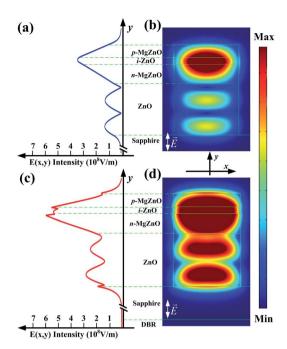


Fig. 3 The electromagnetic field distribution of the major component E(x, y) for the model without DBR (b) and with DBR (d); the electrical field intensity of the fundamental mode of the device without (a) and with (c) the reflector.

reflection and be confined into the heterostructure. Actually, how to increase the extraction efficiency has been one of the major issues for LEDs, and many strategies such as photonic crystal, textured surface, surface plasmon, etc. have been employed to increase the extraction efficiency of LEDs.34-39

To increase the extraction efficiency of ZnO LEDs, a distributed Bragg reflector (DBR) which has a relatively high reflectivity at around 400 nm (corresponding to the emission wavelength of the ZnO LEDs) has been bonded on the backside of the device, and the distribution of the emission electromagnetic field from the device with the DBR is shown in Fig. 3(d). By comparing the electromagnetic field distribution of the device without the DBR (shown in 3(b)) and that of the device with the DBR (shown in Fig. 3(d)), one can see that the reflector can obviously enhance electromagnetic field feedback, and the number of photons that can get out of the device and be captured by the recording detector increased significantly. The quantified enhancement of the electromagnetic field distribution curve along the y-axis were labelled in Fig. 3(a) (without DBR) and Fig. 3(c) (with DBR). At the same calculation condition, the electrical field intensity shows obviously higher magnitude than that without the DBR at the top surface of the device, which reveals that the photons that can come out of the device and be captured by the recording detectors can be increased significantly by the reflector.

To test the validity of the above simulation results, the emission of the LEDs with and without the reflector under the same injection current of 70 mA has been recorded, as shown in Fig. 4. Note that the DBR is commercial available, and is comprised by several pairs of Ta<sub>2</sub>O<sub>5</sub>/SiO<sub>2</sub>. One can see from the

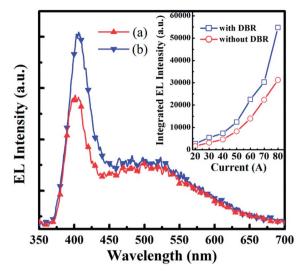


Fig. 4 The emission spectrum of the double heterostructure LEDs with (b) and without (a) the reflector. The inset shows the dependence of the integrated intensity of the emission at around 400 nm on the injection current with and without the DBR.

figure that the emission of the LEDs with the reflector at around 400 nm has been enhanced significantly, while that at around 500 nm changes little compared with that of the device without the reflector. The dependence of the integrated intensity of the emission at around 400 nm on the injection current with and without the DBR is shown in the inset of Fig. 4. One can see that the integrated intensity with the DBR is about 1.6 times larger than that without the reflector in all the investigated cases, which confirms the validity of the reflector in enhancing the emission of the LEDs, as revealed by the simulation results shown in Fig. 3.

To understand the effect of the reflector better, the reflection spectrum of the DBR is shown in Fig. 5. One can see that the reflector shows a reflectivity of about 98% in the spectrum region

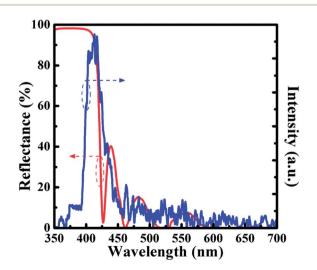


Fig. 5 The reflection spectrum of the DBR and the enhancement ratio of the device by subtracting the emission intensity of the device without the reflector from that with the reflector.

at around 400 nm, while that at longer wavelength is very small. To confirm that the emission enhancement of the LEDs bonded with the DBR is caused by the reflector, the difference between the emission intensity of device with and without the reflector obtained by subtracting the emission intensity of the LEDs without the reflector from that of the LEDs with the reflector is also shown in Fig. 5. One can see that the enhancement occurs mainly in the high reflectivity region of the reflector, and the difference spectra and the reflectivity of the DBR share the same edge, which confirms that the enhancement is caused by the DBR. The above facts reveal that the extraction efficiency of the ZnO LEDs can be increased greatly by using a DBR.

#### Conclusions

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In conclusion, n-Mg $_{0.13}$ Zn $_{0.87}$ O/i-ZnO/p-Mg $_{0.13}$ Zn $_{0.87}$ O double heterostructured LEDs have been constructed, and obvious emission at around 400 nm have been obtained from the heterostructure. A DBR has been bonded backside the device to enhance the light extraction from the device, and the emission of the LEDs has been increased noticeably. FDTD method has been employed to confirm that the reflector is effective in enhancing the emission from the top surface of the devices. The results reported in this communication may provide a route to increase the emission of ZnO-based LEDs.

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### Notes and references

- 1 D. C. Look, Mater. Sci. Eng., B, 2001, 80, 383-387.
- 2 U. Özgür, Y. I. Alivov, C. Liu, A. Teke, M. A. Reshchikov, S. Doğan, V. Avrutin, S. J. Cho and H. Morkoç, J. Appl. Phys., 2005, 98, 041301.
- 3 H. Dong, Y. Liu, J. Lu, Z. Chen, J. Wang and L. Zhang, *J. Mater. Chem. C*, 2013, **1**, 202–206.
- 4 Z. M. Bai, X. Q. Yan, X. Chen, Y. Cui, P. Lin, Y. W. Shen and Y. Zhang, *RSC Adv.*, 2013, **3**, 17682–17688.
- 5 B. Panigrahy and D. Bahadur, RSC Adv., 2012, 2, 6222.
- 6 A. Tsukazaki, A. Ohtomo, T. Onuma, M. Ohtani, T. Makino, M. Sumiya, K. Ohtani, S. F. Chichibu, S. Fuke, Y. Segawa, H. Ohno, H. Koinuma and M. Kawasaki, *Nat. Mater.*, 2004, 4, 42–46.
- 7 S. Chu, J. H. Lim, L. J. Mandalapu, Z. Yang, L. Li and J. L. Liu, *Appl. Phys. Lett.*, 2008, **92**, 152103.
- 8 J. C. Sun, H. W. Liang, J. Z. Zhao, J. M. Bian, Q. J. Feng, L. Z. Hu, H. Q. Zhang, X. P. Liang, Y. M. Luo and G. T. Du, *Chem. Phys. Lett.*, 2008, 460, 548–551.
- 9 Z. P. Wei, Y. M. Lu, D. Z. Shen, Z. Z. Zhang, B. Yao, B. H. Li, J. Y. Zhang, D. X. Zhao, X. W. Fan and Z. K. Tang, *Appl. Phys. Lett.*, 2007, **90**, 042113.

- H. Shen, C. X. Shan, J. S. Liu, B. H. Li, Z. Z. Zhang and D. Z. Shen, *Phys. Status Solidi B*, 2013, 250, 2102–2105.
- 11 J. S. Liu, C. X. Shan, H. Shen, B. H. Li, Z. Z. Zhang, L. Liu, L. G. Zhang and D. Z. Shen, *Appl. Phys. Lett.*, 2012, **101**, 011106.
- 12 Y. S. Choi, J. W. Kang, B. H. Kim, D. K. Na, S. J. Lee and S. J. Park, *Opt. Express*, 2013, 21, 11698–11704.
- 13 K. Nakahara, S. Akasaka, H. Yuji, K. Tamura, T. Fujii, Y. Nishimoto, D. Takamizu, A. Sasaki, T. Tanabe, H. Takasu, H. Amaike, T. Onuma, S. F. Chichibu, A. Tsukazaki, A. Ohtomo and M. Kawasaki, Appl. Phys. Lett., 2010, 97, 013501.
- 14 H. Zheng, Z. X. Mei, Z. Q. Zeng, Y. Z. Liu, L. W. Guo, J. F. Jia, Q. K. Xue, Z. Zhang and X. L. Du, *Thin Solid Films*, 2011, 520, 445–447.
- 15 Y. I. Alivov, J. E. Van Nostrand, D. C. Look, M. V. Chukichev and B. M. Ataev, *Appl. Phys. Lett.*, 2003, **83**, 2943.
- 16 E. Nannen, T. Kümmell, A. Ebbers and G. Bacher, *Appl. Phys. Express*, 2012, **5**, 035001.
- 17 S. Chu, M. Olmedo, Z. Yang, J. Kong and J. Liu, *Appl. Phys. Lett.*, 2008, **93**, 181106.
- 18 H. Kato, T. Yamamuro, A. Ogawa, C. Kyotani and M. Sano, *Appl. Phys. Express*, 2011, 4, 091105.
- 19 H. Long, S. Li, X. Mo, H. Wang, H. Huang, Z. Chen, Y. Liu and G. Fang, *Appl. Phys. Lett.*, 2013, **103**, 123504.
- 20 J. Y. Kong, L. Li, Z. Yang and J. L. Liu, *J. Vac. Sci. Technol., B: Nanotechnol. Microelectron.: Mater., Process., Meas., Phenom.*, 2010, **28**, C3D10–C3D12.
- 21 S. K. Pandey, S. Verma and S. Mukherjee, *Int. J. Mater. Sci. Eng.*, 2013, **1**, 1–4.
- 22 J. Lee, S. Cha, J. Kim, H. Nam, S. Lee, W. Ko, K. L. Wang, J. Park and J. Hong, *Adv. Mater.*, 2011, 23, 4183–4187.
- 23 G. Li, A. Sundararajan, A. Mouti, Y. J. Chang, A. R. Lupini, S. J. Pennycook, D. R. Strachan and B. S. Guiton, *Nanoscale*, 2013, 5, 2259–2263.
- 24 J. B. Yi, C. C. Lim, G. Z. Xing, H. M. Fan, L. H. Van, S. L. Huang, K. S. Yang, X. L. Huang, X. B. Qin, B. Y. Wang, T. Wu, L. Wang, H. T. Zhang, X. Y. Gao, T. Liu, A. T. S. Wee, Y. P. Feng and J. Ding, *Phys. Rev. Lett.*, 2010, **104**, 137201.
- 25 X. Y. Chen, Z. Z. Zhang, B. Yao, M. M. Jiang, S. P. Wang, B. H. Li, C. X. Shan, L. Liu, D. X. Zhao and D. Z. Shen, *Appl. Phys. Lett.*, 2011, 99, 091908.
- 26 X. H. Wang, B. Yao, D. Z. Shen, Z. Z. Zhang, B. H. Li, Z. P. Wei, Y. M. Lu, D. X. Zhao, J. Y. Zhang, X. W. Fan, L. X. Guan and C. X. Cong, *Solid State Commun.*, 2007, 141, 600–604.
- 27 J. S. Liu, C. X. Shan, B. H. Li, Z. Z. Zhang, K. W. Liu and D. Z. Shen, Opt. Lett., 2013, 38, 2113–2115.
- 28 F. K. Shan, G. X. Liu, W. J. Lee and B. C. Shin, *J. Appl. Phys.*, 2007, **101**, 053106.
- 29 S. H. Jeong, B. S. Kim and B. T. Lee, Appl. Phys. Lett., 2003, 82, 2625–2627.
- 30 O. Lupan, T. Pauporte and B. Viana, *Adv. Mater.*, 2010, 22, 3298–3302.
- 31 H. Zhu, C. X. Shan, B. Yao, B. H. Li, J. Y. Zhang, Z. Z. Zhang, D. X. Zhao, D. Z. Shen, X. W. Fan, Y. M. Lu and Z. K. Tang, Adv. Mater., 2009, 21, 1613.

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32 A. Taflove and S. C. Hagness, *Computational Electrodynamics: The Finite-Difference Time-Domain Method*, Artech House,

- Norwood, MA, 2000.
  33 J. W. Pan, P. J. Tsai, K. D. Chang and Y. Y. Chang, *Appl. Opt.*, 2013, 52, 1358–1367.
- 34 Q. Qiao, C. X. Shan, J. Zheng, B. H. Li, Z. Z. Zhang, L. G. Zhang and D. Z. Shen, *J. Mater. Chem.*, 2012, 22, 9481.
- 35 H. Shen, C. X. Shan, Q. Qiao, J. S. Liu, B. H. Li and D. Z. Shen, *J. Mater. Chem. C*, 2013, **1**, 234–237.
- 36 H. Chen, H. Guo, P. Zhang, X. Zhang, H. Liu, S. Wang and Y. Cui, *Appl. Phys. Express*, 2013, **6**, 022101.
- 37 H. Guo, X. Zhang, H. Chen, P. Zhang, H. Liu, H. Chang, W. Zhao, Q. Liao and Y. Cui, *Opt. Express*, 2013, 21, 21456– 21465
- 38 X. Liu, W. Zhou, Z. Yin, X. Hao, Y. Wu and X. Xu, *J. Mater. Chem.*, 2012, **22**, 3916–3921.
- 39 J. T. Lian, J. H. Ye, J. Y. Liou, K. C. Tsao, N. C. Chen and T. Y. Lin, *J. Mater. Chem. C*, 2013, **1**, 6559–6564.